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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/615,084	07/07/2003	Salvatore Lombardo	856063.547D1	7985
500	7590	05/19/2005	EXAMINER	
SEED INTELLECTUAL PROPERTY LAW GROUP PLLC 701 FIFTH AVE SUITE 6300 SEATTLE, WA 98104-7092			SEFER, AHMED N	
		ART UNIT		PAPER NUMBER
				2826

DATE MAILED: 05/19/2005

Please find below and/or attached an Office communication concerning this application or proceeding.

Office Action Summary	Application No.	Applicant(s)	
	10/615,084	LOMBARDO ET AL. <i>PM</i>	
	Examiner	Art Unit	
	A. Sefer	2826	

-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address --
Period for Reply

A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION.

- Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.
- If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely.
- If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.
- Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).

Status

1) Responsive to communication(s) filed on 16 February 2005.
 2a) This action is FINAL. 2b) This action is non-final.
 3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

Disposition of Claims

4) Claim(s) 1-18 is/are pending in the application.
 4a) Of the above claim(s) _____ is/are withdrawn from consideration.
 5) Claim(s) _____ is/are allowed.
 6) Claim(s) 1-18 is/are rejected.
 7) Claim(s) _____ is/are objected to.
 8) Claim(s) _____ are subject to restriction and/or election requirement.

Application Papers

9) The specification is objected to by the Examiner.
 10) The drawing(s) filed on _____ is/are: a) accepted or b) objected to by the Examiner.
 Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).
 Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).
 11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.

Priority under 35 U.S.C. § 119

12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).
 a) All b) Some * c) None of:
 1. Certified copies of the priority documents have been received.
 2. Certified copies of the priority documents have been received in Application No. _____.
 3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).

* See the attached detailed Office action for a list of the certified copies not received.

Attachment(s)

1) <input checked="" type="checkbox"/> Notice of References Cited (PTO-892)	4) <input type="checkbox"/> Interview Summary (PTO-413)
2) <input type="checkbox"/> Notice of Draftsperson's Patent Drawing Review (PTO-948)	Paper No(s)/Mail Date. _____
3) <input type="checkbox"/> Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) Paper No(s)/Mail Date _____	5) <input type="checkbox"/> Notice of Informal Patent Application (PTO-152)
	6) <input type="checkbox"/> Other: _____

DETAILED ACTION

Response to Amendment

1. The amendment filed on February 16, 2005 has been entered; no new claims have been introduced.

Response to Arguments

2. Applicant's arguments filed 2/16/2005 have been fully considered but they are not persuasive. Applicants argue that the APA does not teach or fairly suggest all the elements either explicitly or inherently. Examiner respectfully disagrees and reiterates that there are no structural differences between the claimed invention and the admitted prior art (APA) except for the formation of said first thin dielectric by chemical vapor deposition or carried out by an atmospheric pressure chemical vapor deposition process or said deposition being followed by thermal deposition recited in claims 14-16 respectively, which refers to a process and "product by process" claims are directed to the product per se, no matter how actually made, *In re Hirao*, 190 USPQ 15 at 17 (footnote 3). See also *In re Brown*, 173 USPQ 685 and *In re Thorpe*, 227 USPQ 964, 966. Therefore, the way the product was made does not carry any patentable weight as long as the claims are directed to a device. Further, note that the applicant has the burden of proof in such cases, as the above case law makes clear. Also see MPEP 2113.

Drawings

3. The drawings are objected to under 37 CFR 1.83(a). The drawings must show every feature of the invention specified in the claims. Therefore, the limitation "... the contact region directly contacting the heterostructure alloy of the second conducting region in the

heterostructure alloy region" recited in claim 1 must be shown or the feature(s) canceled from the claim(s). No new matter should be entered.

The drawings are objected to as failing to comply with 37 CFR 1.84(p)(4) because reference characters "12" and "12'" have both been used to designate a dielectric layer in fig. 9C. Corrected drawing sheets in compliance with 37 CFR 1.121(d) are required in reply to the Office action to avoid abandonment of the application. Any amended replacement drawing sheet should include all of the figures appearing on the immediate prior version of the sheet, even if only one figure is being amended. Each drawing sheet submitted after the filing date of an application must be labeled in the top margin as either "Replacement Sheet" or "New Sheet" pursuant to 37 CFR 1.121(d). If the changes are not accepted by the examiner, the applicant will be notified and informed of any required corrective action in the next Office action. The objection to the drawings will not be held in abeyance.

Figure 8 should be designated by a legend such as --Prior Art-- because only that which is old is illustrated. See MPEP § 608.02(g). Corrected drawings in compliance with 37 CFR 1.121(d) are required in reply to the Office action to avoid abandonment of the application. The replacement sheet(s) should be labeled "Replacement Sheet" in the page header (as per 37 CFR 1.84(c)) so as not to obstruct any portion of the drawing figures. If the changes are not accepted by the examiner, the applicant will be notified and informed of any required corrective action in the next Office action. The objection to the drawings will not be held in abeyance.

Corrected drawing sheets in compliance with 37 CFR 1.121(d) are required in reply to the Office action to avoid abandonment of the application. Any amended replacement drawing sheet should include all of the figures appearing on the immediate prior version of the sheet,

even if only one figure is being amended. The figure or figure number of an amended drawing should not be labeled as "amended." If a drawing figure is to be canceled, the appropriate figure must be removed from the replacement sheet, and where necessary, the remaining figures must be renumbered and appropriate changes made to the brief description of the several views of the drawings for consistency. Additional replacement sheets may be necessary to show the renumbering of the remaining figures. Each drawing sheet submitted after the filing date of an application must be labeled in the top margin as either "Replacement Sheet" or "New Sheet" pursuant to 37 CFR 1.121(d). If the changes are not accepted by the examiner, the applicant will be notified and informed of any required corrective action in the next Office action. The objection to the drawings will not be held in abeyance.

Claim Rejections - 35 USC § 102

4. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless –

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

5. Claims 1-7 are rejected under 35 U.S.C. 102(b) as being anticipated by admitted prior art ("APA").

The APA discloses in figs. 1 and 3 a heterostructure bipolar transistor, comprising: a substrate comprised of a first semiconductor material doped with impurities of a first type, the substrate including a first conducting region 5; a heterostructure alloy region positioned in the substrate and comprised of a heterostructure alloy of atoms of the first semiconductor material

and atoms of a second semiconductor material (figs. 3A and 3B); a base region 3 positioned in the substrate above the first conducting region and doped with impurities of a second type; a first dielectric layer 12 positioned on the substrate/ directly contacting the heterostructure alloy of the heterostructure alloy region (as in claim 2), the first dielectric layer defining a first window directly above the heterostructure alloy region; a second conducting region 4 positioned in the heterostructure alloy region and between the first window and the base region, the second conducting region being comprised of the heterostructure alloy doped with impurities of the first type; and a contact region 7 positioned in the first window and comprised of the first semiconductor material, the contact region directly contacting the heterostructure alloy of the second conducting region in the heterostructure alloy region.

As for claim 3, the APA discloses a protective layer 11 positioned over the semiconductor substrate and defining a second window above the heterostructure alloy region, the first dielectric layer being positioned in the second window between the protective layer and the first window.

As for claim 4, the APA discloses a second dielectric layer 14 positioned on the first dielectric layer and in the second window between the protective layer and the first window.

As for claim 5, the APA discloses the first dielectric layer being silicon dioxide and the second dielectric layer being silicon nitride.

As for claim 6, the APA discloses the first semiconductor material being silicon, the second semiconductor material being germanium.

As for claim 7, the APA discloses a metal contact 8 formed directly on the contact region.

6. Claims 8-13 are rejected under 35 U.S.C. 102(b) as being anticipated by APA.

The APA discloses a heterostructure bipolar transistor, comprising: a substrate comprised of a first semiconductor material doped with impurities of a first type, the substrate including a first conducting region 5; a heterostructure alloy region positioned in the substrate and comprised of a heterostructure alloy of atoms of the first semiconductor material and atoms of a second semiconductor material (fig. 3A); a base region 3 positioned in the substrate above the first conducting region and doped with impurities of a second type; a first dielectric layer 12 positioned on, and directly contacting, the heterostructure alloy region, the first dielectric layer defining a first window directly above the heterostructure alloy region; and a second conducting region 4 positioned in the heterostructure alloy region and between the first window and the base region, the second conducting region being comprised of the heterostructure alloy doped with impurities of the first type and directly contacting the first dielectric layer.

As for claim 9, the APA discloses a protective layer 11 positioned over the semiconductor substrate and defining a second window above the heterostructure alloy region, the first dielectric layer being positioned in the second window between the protective layer and the first window.

As for claim 10, the APA discloses a second dielectric layer 14 positioned on the first dielectric layer and in the second window between the protective layer and the first window.

As for claim 11, the APA discloses the first dielectric layer being silicon dioxide and the second dielectric layer being silicon nitride.

As for claim 12, the APA discloses the first semiconductor material being silicon, the second semiconductor material being germanium.

As for claim 13, the APA discloses a contact region 7 positioned in the first window and comprised of the first semiconductor material, the contact region directly contacting the heterostructure alloy of the second conducting region in the heterostructure alloy region; and a metal contact 8 formed directly on the contact region.

7. Claims 14-18 are rejected under 35 U.S.C. 102(b) as being anticipated by APA.

The APA discloses a vertical structure high carrier mobility bipolar transistor, comprising substrate of crystalline silicon doped with impurities of the N type, having a collector region 2 located at a lower portion of the substrate, the transistor being obtained by a process that includes: defining a window above the substrate; providing a first implantation of germanium atoms through said window into the substrate; providing a second implantation of acceptor dopants through said window to define a base region in the substrate (figs. 3A and 3B); applying an RTA treatment, or treatment in an oven, to re-construct a crystal lattice within the semiconductor substrate comprising a silicon/germanium alloy; forming a first thin dielectric layer 12 of silicon dioxide on the substrate; depositing a second dielectric layer 14 or silicon nitride (as in claim 17) onto said first dielectric layer; depositing a polysilicon layer 15 onto said second dielectric layer; etching away, within the window region, said first and second dielectric layers, and the polysilicon layer, to expose the base region and form isolation spacers at edges of the window (fig. 3D); and forming an N-doped emitter 4 directly contacting the first dielectric layer (as in claim 18) in the base and window regions.

As to the formation of said first thin dielectric by chemical vapor deposition or carried out by an atmospheric pressure chemical vapor deposition process or said deposition being followed by thermal deposition recited in claims 14-16 respectively, it refers to a process and

"product by process" claims are directed to the product per se, no matter how actually made, *In re Hirao*, 190 USPQ 15 at 17 (footnote 3). See also *In re Brown*, 173 USPQ 685 and *In re Thorpe*, 227 USPQ 964, 966. Therefore, the way the product was made does not carry any patentable weight as long as the claims are directed to a device. Further, note that the applicant has the burden of proof in such cases, as the above case law makes clear. Also see MPEP 2113.

Conclusion

THIS ACTION IS MADE FINAL. Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

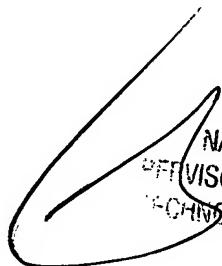
A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the mailing date of this final action.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to A. Sefer whose telephone number is (571) 272-1921

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nathan Flynn can be reached on (571) 272-1915.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <http://pair-direct.uspto.gov>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

ANS
May 15, 2005



NATHAN J. FLYNN
OFTVISORY PATENT EXAMINER
TECHNOLOGY CENTER 2800